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THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Shigeki ITO et al.

Art Unit: 1794

Application Number: 10/573,035

Examiner: Lauren E. Robinson

Filed: March 22, 2006

Confirmation Number: 4409

For:

ANTISTATIC GLASS SUBSTRATE PRODUCTION METHOD AND ANTISTATIC GLASS SUBSTRATE PRODUCED BY THE METHOD

Attorney Docket Number:

062258

Customer Number:

38834

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

September 19, 2008

Sir:

This paper is submitted in response to the Office Action dated August 25, 2008.

Applicants hereby elect the subject matter of Group I, Claims 1, 2 and 4 for prosecution in this application. This election is made without traverse, and it is understood that Applicants' rights to the filing of a divisional application directed to the non-elected subject matter under 35 U.S.C. §120 and 35 U.S.C. §121 are retained.

Application No.: 10/573,035 Response to Restriction Requirement

Art Unit: 1794 Attorney Docket No.: 062258

If this paper is not timely filed, Applicants respectfully petition for an appropriate extension of time. The fees for such an extension or any other fees that may be due with respect to this paper may be charged to Deposit Account No. 50-2866.

Respectfully submitted,

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SGA/nrp